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APPLICATION NO. FILING DATE		LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/618,055	C	07/11/2003	Robert J. Weber	502224	4319	
23626	7590	09/09/2004		EXAMINER		
		IAYER, LTD	ROJAS, BERNARD			
6815 WEAVER ROAD ROCKFORD, IL 61114-8018				ART UNIT	PAPER NUMBER	
				2832		

DATE MAILED: 09/09/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application	on No.	Applicant(s)					
			55	WEBBER ET AL.					
	Office Action Summary	Examiner		Art Unit					
		Bernard F	Rojas	2832					
Period fo	The MAILING DATE of this communication reply	on appears on the	cover sheet with the c	orrespondence ad	Idress				
THE - Exte after - If the - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR F MAILING DATE OF THIS COMMUNICAT nsions of time may be available under the provisions of 37 C SIX (6) MONTHS from the mailing date of this communicati e period for reply specified above is less than thirty (30) days to period for reply is specified above, the maximum statutory are to reply within the set or extended period for reply will, by reply received by the Office later than three months after the ed patent term adjustment. See 37 CFR 1.704(b).	ION.  FR 1.136(a). In no evolution.  In a reply within the state period will apply and with state apply and with a state apply and with state apply and with a state apply apply apply and with a state apply apply and with a state apply	ent, however, may a reply be tim story minimum of thirty (30) days Il expire SIX (6) MONTHS from ication to become ABANDONEI	ely filed s will be considered time the mailing date of this c O (35 U.S.C. § 133).					
Status									
1)⊠	Responsive to communication(s) filed on	01 June 2004.							
•	•	This action is n	on-final.						
3)□	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
Disposit	ion of Claims								
5) <u></u> 6)⊠	Claim(s) 1-31 is/are pending in the application.  4a) Of the above claim(s) is/are withdrawn from consideration.  Claim(s) is/are allowed.  Claim(s) 1-31 is/are rejected.  Claim(s) is/are objected to.  Claim(s) are subject to restriction and/or election requirement.								
Applicat	ion Papers								
10)⊠	The specification is objected to by the Example The drawing(s) filed on <u>01 June 2004</u> is/a Applicant may not request that any objection to Replacement drawing sheet(s) including the other oath or declaration is objected to by the contraction of the contractio	re: a)⊠ accepto to the drawing(s) b correction is requir	e held in abeyance. See ed if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 C	FR 1.121(d).				
Priority (	under 35 U.S.C. § 119								
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) All b) Some * c) None of:  1. Certified copies of the priority documents have been received.  2. Certified copies of the priority documents have been received in Application No  3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.									
	ce of References Cited (PTO-892)	40)	4) Interview Summary						
3) 🔲 Infor	ce of Draftsperson's Patent Drawing Review (PTO-94 mation Disclosure Statement(s) (PTO-1449 or PTO/9 er No(s)/Mail Date		Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:		O-152)				

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## **DETAILED ACTION**

## Drawings

The drawings were received on 06/01/04. These drawings are acceptable.

## Claim Rejections - 35 USC § 103

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-15, 16-22 and 25-30 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ma [US 6,531,668] in view of Yao [US 5,578,976].

Claim 1, Ma discloses a micro-cantilever device [figure 3A, 3B] with a base section [22], a cantilever section [220] having a length and a tapered width along the

length; the cantilever section connected to the base section [at 90], the tapered width a function of position along the length.

Ma fails to teach that the cantilever has a minimum width at the base section.

Yao teaches a tapered cantilever that has a minimum width at the base section [figure 1].

It would have been obvious to one having ordinary skill in the art at the time the invention was made to combine the two teachings and taper the cantilever arm of Ma as suggested by Yao in order to reduce the force required to actuate the cantilever by providing a smaller cantilever cross-section adjacent to the base while still maintaining a relatively large contact area.

Claims 2-7 and 25, it would have been obvious to one of ordinary skill in the art at the time the invention was made to custom tailor the taper function in order to adjust the resonant frequency of the beam.

Claim 8, Yao shows a ground plane [16] is below a portion of the cantilever section.

Claim 9, Ma shows the micro-cantilever has a pull-in voltage that is calculated as a function of the dimensions of the cantilever section and material properties of the cantilever section [col. 5 lines 15-21]. Ma teaches that the cantilever geometry will change its resonance frequency by altering the effective spring-constant-to-mass ratio. This will cause the pull-in voltage formula to change depending on the resonant frequency obtained by the new geometry.

Claims 10-16 and 28-29, it would have been obvious to one having ordinary skill in the art at the time the invention was made to calculate the pull-in voltage since it was known in the art that the function controlling the cantilever pull-in voltage depends on the cantilever length, taper and material from which it is constructed [col. 5 lines 15-21]. Ma teaches that the cantilever geometry will change its resonance frequency by altering the effective spring-constant-to-mass ratio. This will cause the pull-in voltage formula to change depending on the resonant frequency obtained by the new geometry.

Claims 17 and 21, Ma discloses the claimed invention with the exception of using windows on the cantilever.

Yao teaches using windows [28] on the cantilever [20] to in order to enhance switch actuation performance by reducing the weight of the cantilever [col. 3 lines 41-49].

It would have been obvious to one of ordinary skill in the art at the time the invention was made to provide holes on the cantilever of Ma in order to enhance switch actuation performance by reducing the structural mass of cantilever arm and the squeeze film damping effect of air during actuation of switch [Yao, col. 3 lines 41-49].

Claim 18, Yao teaches a micro-cantilever device which has an axis about which the micro-cantilever is symmetric and that at least one open window is located on the axis [figure 1].

Claim 19, Ma teaches a micro-cantilever device [figure 4A-4C] with a base section [90], a cantilever section [420] having a length and a tapered width along the length, the cantilever section connected to the base section, the tapered width a

function of position along the length and a second base section [90] wherein the cantilever is attached to the second base section.

Claim 20, Yao shows a ground plane [16] is below a portion of the cantilever section.

Claim 22, Yoa discloses a strain refile at the base section in the form or a reduced cantilever cross-section [figure 1].

Claim 23, the reduced cantilever cross-section of Yao acts as a lateral stress relief for a cantilever section.

Claim 24, Ma and Yao discloses Mem switches manufactured using well known manufacturing processes. It would have been obvious to one having ordinary skill in the art at the time the invention was made to manufacture the micro-cantilever device using a Multi-user Micro-Electro-Mechanical Systems Process since it was known in the art that it is a standard Mem manufacturing process along with lithography, and chemical vapor deposition.

Claims 26, 27, 30 and 31, It would have been obvious to one of ordinary skill in the art at the time the invention was made to determine the pull-in voltage formula of the cantilever depending on its geometry [col. 5 lines 15-21]. Ma teaches that the cantilever geometry will change its resonance frequency by altering the effective spring-constant-to-mass ratio. This will cause the pull-in voltage formula to change depending on the resonant frequency obtained by the new geometry.

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Response to Arguments

Applicant's arguments with respect to claims 1-31 have been considered but are

moot in view of the new ground(s) of rejection.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in

this Office action. Accordingly, THIS ACTION IS MADE FINAL. See MPEP

§ 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37

CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE

MONTHS from the mailing date of this action. In the event a first reply is filed within

TWO MONTHS of the mailing date of this final action and the advisory action is not

mailed until after the end of the THREE-MONTH shortened statutory period, then the

shortened statutory period will expire on the date the advisory action is mailed, and any

extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

the advisory action. In no event, however, will the statutory period for reply expire later

than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Bernard Rojas whose telephone number is (571) 272-

1998. The examiner can normally be reached on M-F 8-4:00), every other Friday off.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Elvin G. Enad can be reached on (571) 272-1990. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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